



06-16-03 1745

Filed Via Express Mail pursuant to 37 C.F.R. 1.10

Rec. No.: EV 332 276 455 US

On: JUNE 13, 2003

By: *Linda E. Hastings*

LINDA E. HASTINGS

Any fee due as a result of this paper, not covered by an enclosed check, may be charged on Deposit Acct. No. 50-1290.

#6  
sa  
6/19/03

Attorney Docket No.: NEKA 18.612

RECEIVED  
JUN 18 2003  
TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Yoshihisa MATSUBARA et al.

Serial No.: 09/840,386

Filed: April 23, 2001

Title: **METHOD FOR MANUFACTURING SEMICONDUCTOR  
DEVICE, AND PROCESSING SYSTEM AND  
SEMICONDUCTOR DEVICE**

Examiner: Lan Vinh

Group Art Unit: 1765

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

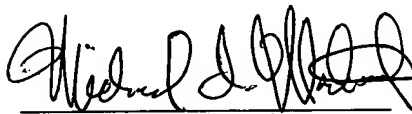
ELECTION

SIR:

In response to the Office Action mailed on May 13, 2003, the period for responding thereto having been set to expire after June 13, 2003, Applicant hereby elects Group I, claims 1-3 and 12, for prosecution at this time. Applicant reserves the right to file continuing application(s) based on claims 4-7 and 8-11. Early examination on the merits is earnestly solicited.

Any fee due with this paper, not fully covered by an enclosed check, may be charged on  
Deposit Account 50-1290.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Michael I. Markowitz", with a long horizontal line extending to the right.

Michael I. Markowitz  
Reg. No. 30,659

KATTEN MUCHIN ZAVIS ROSENMAN  
575 MADISON AVENUE  
NEW YORK, NEW YORK 10022  
(212) 940-8687  
DOCKET NO.: NEKA 18.612  
MIM:lh:  
**CUSTOMER NO.: 026304**